



**RESPONSE TO RESTRICTION  
REQUIREMENT**

Docket No. F0017/7000

Applicant: Jiankang Huang and Robert C. O'Handley  
Serial No: 10/730,355  
Filed: December 8, 2003  
For: HIGH SENSITIVITY, PASSIVE MAGNETIC FIELD SENSOR AND  
METHOD OF MANUFACTURE  
Examiner: C.A. Renner  
Art Unit: 2652

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 12, 2006.

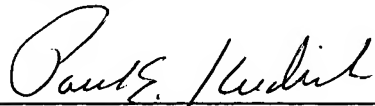
  
Jan L. Mellen

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This is responsive to the restriction requirement dated March 15, 2006. In response to the examiner's restriction, Applicants hereby elect the claims identified as Group I, including claims 1-31. Accordingly, claims 32-42 have been cancelled as drawn to non-elected subject matter.

Any questions regarding this matter may be directed to the undersigned. The Commissioner is hereby authorized to charge any fees due for the filing of this paper to the Applicants' Attorneys' Deposit Account 02-3038.

Respectfully submitted



Date: 4/12/06

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